

CONTENTS

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Engineering Data Sheet		3
Technical Information Special Issue		
Application of Synchrotron Radiation to Nano·Micro Manufacturing	HATTORI Tadashi	5
Nano-order Epitaxial Growth Using Synchrotron Radiation Excited Chemical Reaction ...	{ UTSUMI Yuich HATTORI Tadashi	15
Fabrication of Micro Molding Inserts by LIGA Process Using of Synchrotron Radiation ...	{ KITADANI Takeshi UTSUMI Yuichi HATTORI Tadashi	20
Teflon Micromachining by SR Dry Etching	KATOH Takanori	24
High Quality PTFE Film Formed by SR Direct Etching	Yanping ZHANG	27
Serial Lecture Paper		
Application of Pulsed Electric-Current Sintering Technique to Interfacial Bonding	SAIDA Kazuyoshi	30
Lecture for Practical Engineer		
Welded Joint Strength of Aluminum Thin Structures	{ FUJIWARA Akibumi SASABE Seiji	35
Technical information - Ad hoc Committee Report-		
Development of Joint Design Supporting System	{ HAMADA Kunihiro TAKEICHI Shoji	42
- Basic Studies on Generation and Utilization Methodology of Welding Information in Design and Manufacturing Systems (Phase II) -		
Introduction		
Building up Effectively English Technical Documents (2).....	KATAOKA Hideki	48
Annual Report on Technical Committees		54
Calendar of Event		67
Society Announcements		68

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